

FORM PTO-1449 LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (use several sheets if necessary)	SERIAL NO. 10/668,740	ATTORNEY DOCKET NO. SVL920030067US1
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	APPLICANT(S): Shyh-Mei F. Ho et al.	

REFERENCE DESIGNATION

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	A2	6,128,622	10/03/2000	Bach et al.	707/103	03/13/1998
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	A12	2002/0078010	06/20/2002	Ehrman et al.	707/1	05/04/2001
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EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS/ SUBCLASS	FILING DATE
	A27	2005/0165936	07/28/2005	Haller et al.	709/228	01/26/2004
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	A29	2006/0265478	11/23/2006	Chiang et al.	709/219	07/12/2006

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EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS/ SUBCLASS	TRANSLATION	
						YES	NO
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	A31	JP2001273177	10/05/2001	Japan	G06F 12/00		

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